

09/21/2009

Reply under 37 C.F.R. 1.116
Expedited Procedure
Technology Center 2832

Confirmation No. 3317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DETECHEVERRY	Examiner:	Baisa, Joselito
Serial No.:	10/564,582	Group Art Unit:	2832
Filed:	January 12, 2006	Docket No.:	NL030878US (NXPS.267PA)
Title:	INDUCTIVE AND CAPACITIVE ELEMENTS FOR SEMICONDUCTOR TECHNOLOGIES WITH MINIMUM PATTERN DENSITY REQUIREMENTS		

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No. 65913

Dear Sir:

In response to the Final Office Action dated July 22, 2009, please reconsider the application in view of the following remarks.

A complete Listing of the Claims and Remarks/Arguments follow.